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PATENT APPLICATION
RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuyoshi TAMURA et al.

Group Art Unit: 1765

Application No.: 09/696,955

Examiner: M. A. Anderson

Filed: October 27, 2000

Docket No.: 107703

For: SILICON FOCUS RING AND METHOD FOR PRODUCING THE SAME

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TECHNOLOGY CENTER 1700

JUL - 8 2003

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Sir:

In reply to the April 17, 2003 Final Office Action, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims; and

Remarks.